

## Application Data Sheet

### **Application Information**

Application Type: Regular

Subject Matter: Utility

Suggested Classification:

Suggested Group Art Unit:

CD-ROM or CD-R?: None

Title: METHOD AND APPARATUS FOR REMOVING  
WATER VAPOR AS A BYPRODUCT OF CHEMICAL  
REACTION IN A WAFER PROCESSING CHAMBER

Request for Early Publication?: No

Request for Non-Publication?: Yes

Suggested Drawing Figure: 5

Total Drawing Sheets: 7

Small Entity: No

Petition included?: No

Secrecy Order in Parent Appl.?: No

### **Applicant Information**

Applicant Authority type: Inventor

Primary Citizenship Country: USA

Status: Full Capacity

Given Name: Robert D.

Family Name: Broyles

City of Residence: Battle Ground

State or Province of Residence: WA  
Country of Residence: USA  
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City of mailing address: Battle Ground  
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**Applicant Information**

Applicant Authority type: Inventor  
Primary Citizenship Country: USA  
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Given Name: Michael J.  
Family Name: Berman  
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Postal or Zip Code of mailing address: 97322

**Correspondence Information**

Correspondence Customer Number: 24319

**Representative Information**

Representative Customer Number:	24319
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**Domestic Priority Information**

Application::	Continuity Type:	Parent Application:	Parent Filing Date:
This application	Division of	10/140,536	05/07/2002

**Assignee Information**

Assignee name: LSI Logic Corporation

Street of mailing address: 1551 McCarthy Boulevard

City of mailing address: Milpitas

State or Province of  
mailing address: California

Country of mailing address: USA

Postal or Zip Code of  
mailing address: 95035